



IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Toshiji TAIJI et al.

Conf. 2404

Application No. 10/616,914

Group 1765

Filed July 11, 2003

Examiner L. Umez Eronini

SLURRY FOR CHEMICAL MECHANICAL POLISHING

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

August 31, 2005

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the cited documents are made of record on the enclosed PTO Form-1449.

A concise explanation of the relevance of these items is that these references were cited in an Office Action dated May 31, 2005 in the corresponding Korean Application. A copy of the Official Action in which they were cited is attached hereto, with what is believed to be the pertinent portion enclosed in a wavy line. An English translation of the Japanese enclosed portion is also attached hereto.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first

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cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

Robert J. Patch, Reg. No. 17,355

745 South 23<sup>rd</sup> Street Arlington, VA 22202

Telephone (703) 521-2297

Telefax (703) 685-0573

(703) 979-4709

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INFORMATION DISCLOSURE CITATION			Attorney Docket No.: 8017-1094		Application No.: 10/616,914		
	IN AN APPLICAT		Applicant: Toshiji TAIJI et al.				
(Use several sheets if necessary)			Filing Date: July 11, 2003		Group Art Unit: 1765		
		U.S. PATEN	T DOCUMENTS				
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		FOREIGN PAT	ENT DOCUMENTS				
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	KR2001-20384	03/2001	Korea			-	
	WO 98/49723	11/1998	International			-	
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	OTHER DOCUM	ENTS (Including A	uthor, Title, Date, Pertine	ent Pages, E	tc.)		_
EXAMINER:			DATE CONSIDERED				
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\* Abstract provided for the Examiner's convenience